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Sheet 1 of 1

PTO 1449  37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)				Docket No. <b>P97,0027</b>		Serial No. <b>08/818,239</b>	
				Applicant <b>Hiroshi Tayanaka</b>			
				Filing Date <b>March 14, 1997</b>		Group Art Unit <b>2813</b>	
U.S. PATENT DOCUMENTS							
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
		AA					
		AB					
		AE					
		AD					
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation Yes No
✓		AE EP 0 554 795 A1	Aug. 11, 1993	EPO	—	—	X
✓		AF EP 0 793 263 A2	Sept. 3, 1997	EPO	—	—	X
		AG					
		AH					
		AE					
		AJ					
		AK					
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
✓	AL	Patent Abstracts of Japan, Vol. 010, No. 039 (E-381), 15 February 1986 & JP 60 196955 A (TOKO INC), 5 October 1985					
✓	AM	T. Yasumatsu, et al., "Ultrathin Si films grown epitaxially on porous silicon", Applied Surface Science, Vol. 48/49, May 1991, pages 414-418, XP-002093161					
✓	AN	M. Ohnishi, et al., "NEW TYPE STRUCTURES OF A-SI SOLAR CELL SUBMODULES FABRICATED BY MICROSCOPIC HOLE SPACING TECHNIQUE", RECORD OF THE PHOTOVOLTAIC SPECIALISTS CONFERENCE, KISSIMIMEE, May 21-25, 1990, Vol. 2, No. CONF. 21, 21 May 1990, pages 1394-1399; XP 000480389, INSTITUTE OF ELECTRICAL AND ELECTRONICS ENGINEERS					
✓	AO	Patent Abstracts of Japan, Vol. 018, No. 066 (E-1501), 3 February 1994, & JP 05 283722 A (CANON INC), 29 October 1993					
Examiner	✓ <i>[Signature]</i>		Date Considered <i>5/3/99</i>				
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